



Patent
Attorney's Docket No. 015290-458

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of)	Group Art Unit: 1773
Christopher C. CHANG et al.)	Examiner: Nikolas J. Uhler
Application No.: 09/749,917)	Confirmation No.: 6832
Filed: December 20, 2000)	
For: LOW CONTAMINATION PLASMA)	
CHAMBER COMPONENTS AND)	
METHODS FOR MAKING THE)	
SAME)	

AMENDMENT AFTER FINAL REJECTION

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed February 20, 2004, please amend the
above-identified patent application as follows:

OK to enter
MW
5/27/04